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CONFIRMATION NO. 3893

SERIAL NUMBER 10/019,407	FILING OR 371(c) DATE 03/25/2002 RULE	CLASS 438	GROUP ART UNIT 2813	ATTORNEY DOCKET NO. 520.41003 X00
APPLICANTS Yoshinobu Kimura, Tokyo, JAPAN; Takahiro Kamo, Mobara, JAPAN; Yoshiyuki Kaneko, Hachioji, JAPAN;				
** CONTINUING DATA ***** This application is a 371 of PCT/JP00/04141 06/23/2000				
** FOREIGN APPLICATIONS ***** JAPAN 11/181559 06/28/1999				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Verified and Acknowledged <input checked="" type="checkbox"/> Allowance		STATE OR COUNTRY JAPAN	SHEETS DRAWING 16	TOTAL CLAIMS 20
Examiner's Signature <i>[Signature]</i> Initials <i>[Initials]</i>		INDEPENDENT CLAIMS 9		
ADDRESS 20457				
TITLE Polysilicon semiconductor thin film substrate, method for producing the same, semiconductor device, and electronic device				
FILING FEE RECEIVED 1524	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	